IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Jennifer Stone-Sundberg, et al.

Title:

OPTICAL SPINEL ARTICLES AND METHODS FOR FORMING SAME

Application No.: NEW APPLICATION

Filed:

HEREWITH

Atty. Docket No.: 1035-BI4309

MS PATENT APPLICATION COMMISSIONER FOR PATENTS PO Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT TRANSMITTAL

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the undersigned brings the patents, publications, applications or other information identified in the attached:

\boxtimes	Form(s) PTO/SB/08A and/or PTO/SB/08B
П	Other: n/a

to the Examiner's attention in the above-identified application. These references were cited in parent Application No. 10/669,141, filed September 23, 2003. Accordingly, in accordance with C.F.R. §1.98(d), copies of the references are not being supplied herewith. Citation of such information shall not be construed as:

- 1. an admission that the information necessarily is, or corresponds to, prior art with respect to the instant invention;
- 2. a representation that a search has been made, other than as described below; or
- 3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

For each item of information listed that is not in the English language, the undersigned has provided a concise explanation of the relevance, such as through (i) an English language abstract, (ii) an English language equivalent application, (iii) reference to discussion in the application, or (iv) if cited in a search report or other action by a foreign patent office in a counterpart foreign application, an English language version of the search report or action that indicates the degree of relevance found by the foreign office.

CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as either First Class Mail or Express Mail, in an envelope addressed to the Commissioner for Patents on 3-17-04 Elise K. Dougherty Typed or Printed Name Signature

STATEMENT UNDER 37 C.F.R. § 1.704(d)

May 2	If the a	above-identified application is an original application filed on or after:
		each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application and this communication was not received by any individual designated in § 1.56(c) more than thirty days prior to the filing of this Information Disclosure Statement.
		FEES DUE
	This I	nformation Disclosure Statement is being filed:
	\boxtimes	within three months of the filing date of a national application or within three months of entry of the national stage as set forth in § 1.491 in an international application. Therefore, no fee is required.
		before the mailing date of a first Office action on the merits or before the mailing date of a first Office action after the filing of a request for continued examination under § 1.114. Therefore, no fee is believed required.
		during the period specified in § 1.97(c). Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application not more than three months prior to the filing of this Information Disclosure Statement.
		during the period specified in § 1.97(c). Accordingly, the fee set forth in § 1.17(p) is required and provided as shown on the attached Fee Transmittal.
		during the period specified in § 1.97(d). Accordingly, the fee set forth in § 1.17(p) is required and provided as shown on the attached Fee Transmittal. Additionally, each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application not more than three months prior to the filing of this Information Disclosure Statement.

Should any PTO fees be necessary for entry of this Information Disclosure Statement, the undersigned hereby authorizes the Commissioner to charge Deposit Account 50-2469.

Respectfully submitted,

Jeffred J. Abel, Reg. No. 36,079 Attorney for Applicant(s)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Substitute for form 1449/PTO

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Sheet 1 of 3 (use as many sheets as necessary)

U.S. PATENT DOCUMENTS

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Examiner Initials *	Cite No.1	U.S. Patent Docum Number Kind Coc (if known	de 2	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	AA	3,655,439		SEITER	04/11/1972			
	AB	3,658,586		WANG	04/25/1972			
	AC	3,796,597		V.R. PORTER, et al.	03/12/1974			
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	AL	EP	0 148 656	A1	AUZEL, et al.	11/16/1984		
	AM							

PUBLICATIONS

F T	Cite	Title of Publication			Data of Dublication	
Examiner Initials *	" No.1				Date of Publication of Cited Document MM-DD-YYYY	
	AV	YUMASHEV K.V.,et al., "Co ²⁺ -doped spinels satural 1.3-1.6 μm solid state lasers", OSA TRENDS IN OP ADVANCED SOLID STATE LASERS., Vol. 34, pp. 2 XP008017966	TCS AND PHO			
	AW	YUMASHEV, K.V., et al., "Passive Q-switching of 1. using Co²⁺:LiGa₅O ₈ and Co²⁺:MgAl₂O₄", CONFEREN page. XP002242959				
	AX		TYABRSKY, S., et al., "Crystal structure and defects in nitrogen-deficient N", MRS Internet J. Nitride Semicond. Res, G6.43, pp. 1-6, 1999.			
	AY	KLEBER, W., et al., "Zur epitaxie von galliumnitrid a spinell im system GaCl/NH ₃ /He", CRYSTAL RESEA Vol. 10, No. 7, pp. 747-758, 1975. (English Abstract	RCH AND TECH			
	AZ	SEIFERT, A., "Nachweis von stapelfehlern in GaN-e elektronenbeugung", CRYSTAL RESEARCH AND TNo. 7, pp. 741-746, 1975. (English Abstract)				
Examiner Signature			Date Considered			

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. 2 See attached Kinds of U.S. Patent Documents. 3 Enter Office that issued the document, by the twoletter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

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	BA	6,533,874	B1	VAUDO, et al.	03/18/2003	
	BB	4,627,064		AUZEL, et al.	12/02/1986	
	BC	4,000,977		FALCKENBERG	01/04/1977	
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	ВК					

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	BL							
	ВМ							

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Examiner Initials *	Cite No.1	Title of Publication		Date of Publication of Cited Document MM-DD-YYYY
	BW	OHSATO, H., et al., "Epitaxial orientation and a growth model of thin film on (1 1 1) spinel substrate", JOURNAL OF CRYSTAL 189/190, pp. 202-207, 1998.		
	ВХ	YANG, H. –F., et al., "Microstructure evolution of GaN buffer la substrate", JOURNAL OF CRYSTAL GROWTH, Vol. 193, pp.	yer on MgAl₂O₄ 478-483, 1998.	
	BY	DUAN, S., et al., "MOVPE growth of GaN and LEDon (1 1 1) N JOURNAL OF CRYSTAL GROWTH, Vol. 189/190, pp. 197-20		
	BZ	SHELDON, R., et al., "Cation Disorder and Vacancy Distribution Nonstoichiometric Magnesium Aluminate Spinel, MgO • Al ₂ O ₃ "CERAM. SOC., Vol. 82, No. 12, pp. 3293-3298, 1999.		
Examine Signature	·	Date Conside	red	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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¹ Unique citation designation number. 2 See attached Kinds of U.S. Patent Documents. 3 Enter Office that issued the document, by the twoletter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

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Sheet 3 of 3

(use as many sheets as necessary) PUBLICATIONS

·		as necessary) PUBLICATIONS	
Examiner Initials *	Cite No.1	Title of Publication	Date of Publication of Cited Document MM-DD-YYYY
	AAA	KULESHOV, N.V., et al. "Co-doped spinels: promising materials for solid state lasers", LONGER WAVELENGTH LASERS AND APPLICATIONS, Vol. 2138, pp. 175-182, 1994. XP008017848	
	AAB	KULESHOV, N.V., et al., "Absorption and luminescence of tetrahedral Co ²⁺ ion in MgAl₂O₄, Vol. 55, no. 5-6, pp. 265-269, 1993. XP008017849	
	AAC	NIKISHIN, S.A., et al., "Gas source molecular beam epitaxy of GaN with hydrazine on spinel substrates", APPLIED PHYSICS LETTERS, Vol. 72, No. 19, pp. 2361-2363, 1998. XP000755963	
	AAD	HAISMA, et al., "Lattice constant adaptable crystallographics", JOURNAL OF CRYSTAL GROWTH", Vol. 102, pp. 979-993, 1990. XP002250056	
	AAE	TAMURA, K., et al., "Epitaxial growth of ZnO film on lattice-matched ScAIMgO₄ (0001) substrates", JOURNAL OF CRYSTAL GROWTH, Vol. 214-215, pp. 59-62, 2000. XP004200964	
	AAF	WYON, et al., "Czochralshi growth and optical properties of magnesium- aluminum spinel doped with nickel", JOURNAL OF CRYSTAL GROWTH, Vol. 79, pp. 710-713, 1986. XP002250057	
	AAG	TSUCHIYA, T., et al. " Epitaxial growth of InN films on MgAl ₂ O ₄ (1 1 1) substrates", JOURNAL OF CRYSTAL GROWTH, Vol. 220, pp. 185-190, 2000.	
	AAH	KURAMATA, Akito, et al., "High-quality GaN epitaxial layer grown by metalorganic vapor phase epitazy on (111) MgAl ₂ O ₄ substrate", APPL. PHYS. LETT., Vol. 67, No. 17, pp. 2521-2523, 1995.	
	AAI	MITCHELL, T., "Dislocations and Mechanical Properties of MgO- MgAl ₂ O ₃ spinel single crystals", J. AM. CERAM. SOC., Vol. 82, No. 12, pp. 3305-3316, 1999.	
	AAJ	HELLMAN, E., "Exotic and Mundane substrates for gallium nitride heteroepitaxy", BELL LABORATORIES, THC2, Murray Hill, NJ.	
	AAK	KRUGER, M.B., et al., "Equation of state of MgAl ₂ O ₄ spinel to 65 GPa", THE AMERICAN PHYSICAL SOCIETY, Vol. 56, No. 1, pp. 1-4, 1997.	
	AAL	KURAMATA, A., et al., "Properties of GaN epitaxial layer grown on (111) MgAl₂O₄ substrate", SOLID-STATE ELECTRONICS, Vol. 41, No. 2, pp. 251-254, 1997.	
	AAM	GRITSYNA, V., et al., "Structure and Electronic states of defects in spinel of different compositions MgO • n MgAl ₂ O ₃ :Me", J. AM. CERAM. SOC. Vol. 82. No. 1, pp. 3365-3373, 1999.	
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Signature		Considered	

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LIST OF RELATED APPLICATIONS

Application No.	Filing Date	Applicant(s)	Docket No.
10/669,141	09/23/03	Kokta, et al.	1035-BI4282
10/669,135	09/23/03	Kokta, et al.	1035-BI4307
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